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7471/PPC/CMF/CKIM

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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Robert Tolles, David P. Alvarez and  
Jianshe Tang

Serial No. : 10/736,242

Filed : December 15, 2003

For : MEGASONIC WAFER CLEANING TANK WITH  
REFLECTOR FOR IMPROVED WAFER EDGE  
CLEANING

Examiner : Saeed T. Chaudhry

Group Art Unit : 1746

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

## AMENDMENT &amp; RESPONSE

Sir:

In response to the Office Action mailed January 5,  
2006, please amend the above-identified application as  
follows:

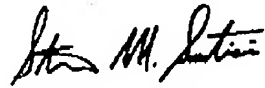
**Amendments to the Claims** begin on page 2 of this paper.

**Remarks/Arguments** begin on page 10 of this paper.

## CERTIFICATE OF MAILING/TRANSMISSION (37 C.F.R. section 1.8(a))

I hereby certify that, on the date shown below, this correspondence is being:

☒ transmitted by facsimile to the U.S. Patent and Trademark Office.



Signature

July 3, 2006

Date

Steven M. Santisi

(name of person certifying)